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PATENT  
0756-1921  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:

Hisashi OHTANI et al.

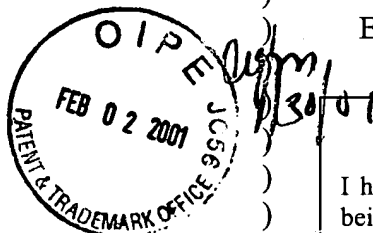
Application No.: 09/226,216

Filed: January 7, 1999

For: SEMICONDUCTOR DEVICE  
AND METHOD OF  
MANUFACTURING THE SAME

Art Unit: 2813

Examiner: L. Schillinger



CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on JAN. 30, 2001

*[Signature]* Luan Ho

AMENDMENT

Commissioner of Patents  
Washington, D.C. 20231

RECEIVED  
FEB 7 2001  
MAIL ROOM  
JAN 30 2001

Dear Sir:

In response to the Examiner's non-final Office Action mailed August 30, 2000, the period for responding having been extended two (2) months, please consider the following amendments and remarks in connection with the above-identified application.

IN THE CLAIMS:

Please amend claims 5, 16, 19, 20 and 23 as follows:

5. (Amended) A method of manufacturing a semiconductor device, comprising the steps

of:

forming a semiconductor film comprising amorphous silicon;

crystallizing the semiconductor film by a heat treatment while a promoting material for facilitating crystallization is retained on [or under] the semiconductor film;

removing the promoting material for facilitating crystallization on the semiconductor

film; and

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*[Signature]*  
 Luan P.

**TRANSMITTAL LETTER**

Commissioner for Patents  
 Washington, D.C. 20231

January 30, 2001

Sir:

Transmitted herewith is an Amendment Under 37 C.F.R. § 1.111 in the above-identified application.

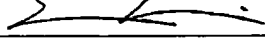
The fees have been calculated as shown below:

	Claims Remaining After Amendment		Highest Number Previously Paid For	Present Extra	Small/Large Entity Rate	Fee
Total	30	Minus	28	2	x \$9/\$18	\$36.00
Indep	5	Minus	4	1	x \$39/\$78	\$78.00
First Presentation of Multiple Dependent Claim					+ \$130/\$260	\$0.00
<b>TOTAL</b>						<b>\$114.00</b>

- [ X ] A Petition for Extension of Time for Two (2) Months is enclosed.
- [ X ] A check in the amount of \$504.00 to cover the extension of time and additional claims fees.
- [ X ] In the event applicant(s) has overlooked the need for any petition and fee for extension of time, and such extension is required, applicant(s) requests that this be considered a petition therefor and that such fee be charged to Deposit Account No. 19-2380 (0756-1921).
- [ X ] The Commissioner is hereby authorized to charge fees under 37 CFR 1.16, 1.17, 1.20(a), 1.20(b), 1.20(c) and 1.20 (d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment, to Deposit Account No. 19-2380 (0756-1921). A duplicate copy of this sheet is attached.

Respectfully submitted,

NIXON PEABODY LLP

By   
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Reg. No. 38,285

EJR/LCD/dlt

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